



AF 28154

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **WATANABE, Kenichi**

Group Art Unit: **2815**

Serial No.: **09/987,012**

Examiner: **Chris C. Chu**

Filed: **November 13, 2001**

P.T.O. Confirmation No.: **6363**

For. **SEMICONDUCTOR WAFER DEVICE HAVING SEPARATED CONDUCTIVE PATTERNS IN PERIPHERAL AREA AND ITS MANUFACTURING METHOD**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: November 12, 2003

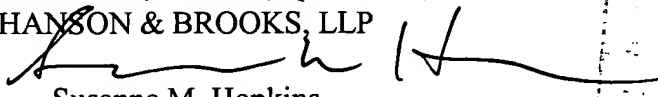
Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated August 1, 2003 for one month from November 1, 2003 to December 1, 2003.

Attached please find a check in the amount of \$110.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, KRATZ, QUINTOS,
HANSON & BROOKS, LLP


Susanne M. Hopkins
Attorney for Applicant
Reg. No. 33,247

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PATENT TRADEMARK OFFICE